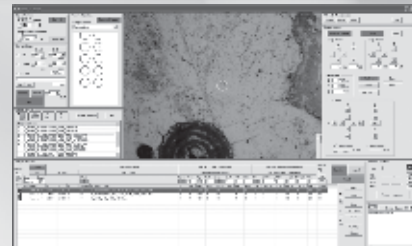
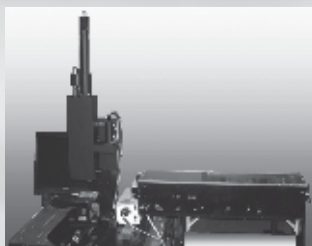


UV 193nm EXCIMER LASER ABLATION SYSTEM

UV 193 · 200 · 266nm Femto Sec LASER ABLATION SYSTEM

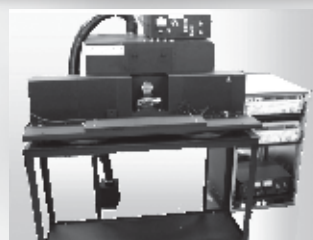
- ◆ Low purchase price
- ◆ Full software for ablation
- ◆ Laser and ICP MS are controllable.
- ◆ Originally designed ablation optics
- ◆ Optics are usable on other Lasers.



INTEGRATED CPM · PDS MEASUREMENT SYSTEM

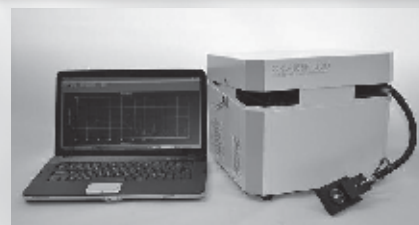
Absorption coefficient measurement for materials of thin film solar cells

- ◆ Interference free measurement
- ◆ Measureable up to long wavelength 0.4eV.
- ◆ Full automatic measurement
- ◆ For quantum efficiency and spectral response



OKL-HSSR1300 SPECTRORADIOMETER FOR PULSE & CONTINUOUS TYPE SOLAR SIMULATOR

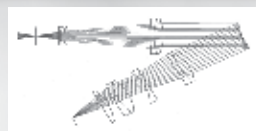
- ◆ For 1m sec pulse light
- ◆ Compact
- ◆ Accurate
- ◆ Steady and stable
- ◆ Originally designed and made by OK Lab.



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- ☆ Laser scanning microscope
- ☆ UV~IR Spectrometer
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